

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination BEAMAN ET AL.	
		09/653,281	Examiner	Art Unit Richard A. Booth 2812

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)		
	U	Hoff et al., "Atomic Oxygen and the thermal oxidation of silicon", Applied Physics Letters 52 (15), April 1988, pages 1264-1265.		
	V			
	W			
	X			

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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